

Stanford

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Ph.D. Student in Materials Science and Engineering, admitted Autumn 2023

Publications

PUBLICATIONS

- **Molecular layer deposition of an Al-based hybrid resist for electron-beam and EUV lithography**
Ravi, A., Shi, J., Lewis, J., Bent, S. F., Guerrero, D., Amblard, G. R.
SPIE-INT SOC OPTICAL ENGINEERING.2023
- **Molecular Layer Deposition of a Hafnium-Based Hybrid Thin Film as an Electron Beam Resist.** *ACS applied materials & interfaces*
Shi, J., Ravi, A., Richey, N. E., Gong, H., Bent, S. F.
2022